



Docket No.: A-69175-1/MSS (463035-650)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named		
Inventor:	Nam P. Suh et al.	
Appln. No.:	10/029,158	
Filing Date:	December 21, 2001	Examiner: RACHUBA,
	APPARATUS AND METHOD FOR	Maurina T.
	CHEMICAL MECHANICAL	
Title:	POLISHING OF SUBSTRATES	Group Art Unit: 3723

PETITION FOR EXTENSION OF PERIOD FOR RESPONSE

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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SEP 21 2004

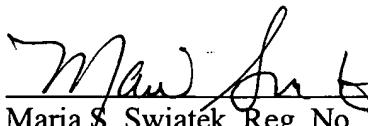
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Dear Sir:

Pursuant to 37 C.F.R. § 1.136(a), Applicant hereby petitions for an extension of 2-month(s) (from July 13, 2004 to September 13, 2004) within which to respond to the Office Action dated April 13, 2004. A check in the amount of \$564.00 (\$144 for additional claims fee, \$420 for 2 month extension fee for large entity) is enclosed herewith to cover the extension fee. Please charge any additional fees or credit any overpayment to our Deposit Account No. 50-2319 (Order No. A-69175-1/MSS (463035-650)).

Respectfully submitted,
DORSEY & WHITNEY LLP

Date: September 13, 2004

By: 

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